

Substitute for form 1449A/PTO

JUL 02 2004

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet

1 of 2

Complete If Known

Application Number	09/893,340
Filing Date	June 26, 2001
First Named Inventor	Sien G. Kang
Art Unit	2813
Examiner Name	Erik J. Kielin

Attorney Docket Number 018419-008320US

U.S. PATENT DOCUMENTS+					
Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ³ (if known)		
EK	1	US-5,403,434		04-04-1995	Moslehi

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)		
EK	2	DE	19753494	A	10-01-1998	Mitsubishi Corp
EK	3	EP	0971395	A	01-12-2000	ASM Epitaxy
EK	4	EP	0296804	A	12-28-1988	Shin-Etsu Handotai Co.

Examiner Signature	<i>Erik J. Kielin</i>	Date Considered	10/20/04
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² Kind Codes of U.S. Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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Substitute for form 1449B/PTC		<i>O I P E JUL 02 2004</i>		<i>Complete if Known</i>	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	09/893,340
Sheet	2	of	2	Filing Date	June 26, 2001
				First Named Inventor	Sien G. Kang
				Art Unit	2813
				Examiner Name	Erik J. Kielin
				Attorney Docket Number	018419-008320US

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
<i>EK</i>	5	HABUKA et al. "Change in Microroughness of a Silicon Surface during In Situ Cleaning Using HF and HCl Gases," J. Electrochem. Soc., 145:4264-4271 (1998).		

Examiner Signature	<i>E. Kielin</i>	Date Considered	<i>10/20/04</i>
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.